

In the Specification

At page 1 before the "Technical Field" section please insert:

--RELATED PATENT DATA

This patent resulted from a divisional application of and claims priority to U.S. Patent Application Serial No. 09/521,092, filed March 7, 2000, entitled Semiconductor Workpiece Processing Methods and Turbidity Monitoring Methods ", naming Scott E. Moore et al. as inventors, which is a divisional of U.S. Patent Application Serial No. 09/324,737, filed June 3, 1999, entitled "Semiconductor Processors, Sensors, and Semiconductor Processing Systems", now U.S. Patent No. 6,290,576, naming Scott E. Moore et al. as inventors, the disclosures of which are incorporated by reference.--